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3/23/02
M. Harrison

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On: FEBRUARY 28, 2002

By: *Linda E. Hastings*

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by
an enclosed check, may be charged on Deposit Acct.
No. 50-1290.

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TECHNOLOGY CENTER 2800

ATTORNEY DOCKET NO. NECK 17.552

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Hiroshi TANABE
Serial No. : 09/614,286
Filed: : July 12, 2000
Title: : **METHOD FOR FORMING SEMICONDUCTOR FILMS
AT DESIRED POSITIONS ON A SUBSTRATE**
Examiner : Timothy J. Sutton
Group Art Unit : 2813

Assistant Commissioner for Patents
Washington, D. C. 20231

PETITION FOR EXTENSION OF TIME

SIR:

Applicant requests that the time for taking action in this case be extended
pursuant to 37 CFR 1.136(a) for:

☒ one month

☐ three months

☐ two months

☐ four months

The fee set in 37 CFR 1.17 for the extension of time is \$110.00

☐ Fee enclosed. Please charge any additional fee required for this extension of time to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.

☒ **Charge fee to Deposit Account No. 50-1290. A duplicate copy of this paper is enclosed.**

☐ Applicant is a small entity entitled to pay reduced fees in this application. A verified small entity statement:

☐ has been filed

☐ is enclosed

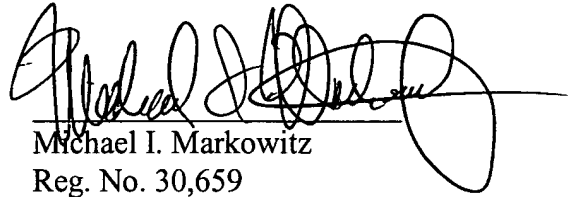
Also enclosed is a:

☒ **Response to Official Action**

☐ Notice of Appeal

☐ Appeal Brief

Respectfully submitted,


Michael I. Markowitz
Reg. No. 30,659

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